

Notice of References Cited	Application/Control No. 10/791,197	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Anastasia Midkiff	Art Unit 2882	Page 1 of 1

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*	B	US-6,437,506	08-2002	Mitamura et al.	313/586
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	L	US-			
	M	US-			

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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